

Electronic Patent Application Fee Transmittal

Application Number:	10625669			
Filing Date:	24-Jul-2003			
Title of Invention:	METHOD FOR PLASMA PROCESSING BY SHAPING AN INDUCED ELECTRIC FIELD			
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Filer:	Marvin Jay Spivak/Mimi Chanthaphone			
Attorney Docket Number:	236664US2RE			
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Utility under 35 USC 111(a) Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Utility Appl issue fee	1501	1	1510	1510
Extension-of-Time:				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Printed copy of patent - no color	8001	1	3	3
Total in USD (\$)				1513